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Substitute for form 1449A/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary)	Complete If Known	
	Application Number	10/659,691
	Filing Date	September 10, 2003
	First Named Inventor	Tseung, Alfred
	Group Art Unit	2832
	Examiner Name	Easthom, Karl
Sheet 1 of 1	Attorney Docket No: 1260.006US2	

US PATENT DOCUMENTS						
Examiner Initial *	USP Document Number	Publication Date	Name of Patentee or Applicant of cited Document	Class	Subclass	Filing Date If Appropriate

FOREIGN PATENT DOCUMENTS						
Examiner Initials *	Foreign Document No	Publication Date	Name of Patentee or Applicant of cited Document	Class	Subclass	T ²

OTHER DOCUMENTS -- NON PATENT LITERATURE DOCUMENTS			
Examiner Initials *	Cite No ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ³
KL		GRACE, J M., et al., "A Review Of Liquid Atomization By Electrical Means", <u>J. Aerosol Science</u> , 25(6), (1994), 1005-1019	
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JK		STELZER, NHJ, et al., "Electrostatic Spray Deposition of Doped YSZ Electrode Materials for a Monolithic Solid Oxide Fuel Cell Design", <u>Laboratory for Applied Inorganic Chemistry, Delft Univ of Tech, Julianalaan 136, 2628 BL Delft, The Netherlands</u> , 236-247	

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EXAMINER	<i>[Signature]</i>	DATE CONSIDERED	2/1/05
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PTO 1449 (10-01)
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Substitute for form 1449A/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary)	Complete if Known	
	Application Number	Unknown 12/659671
	Filing Date	Even Date Herewith
	First Named Inventor	Tseung, Alfred
	Group Art Unit	Unknown
	Examiner Name	Easthorn, Karl
Sheet 1 of 1		Attorney Docket No: 1260.006US2

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OTHER DOCUMENTS -- NON PATENT LITERATURE DOCUMENTS			
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